

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : James S. Im Examiner : Fernando L. Toledo
Serial No. : 10/524,809 Confirmation No. : 1620
Filed : 02/15/2005 Group Art Unit : 2895
For : Single-shot semiconductor processing system and method having various irradiation patterns

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(c), Applicant brings to the attention of the Examiner the documents listed on the attached Form PTO 1449. It is respectfully requested that these documents be made of record in this application by the Examiner's completion and return of the Form PTO-1449.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed documents are material or constitute “prior art.” If the Examiner applies the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute “prior art” under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the documents.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should the documents be applied against the claims of the present application.

Applicant have enclosed the fee due in connection with this submission. If any additional fee is due, or if any overpayment has been made, the Commissioner is authorized to charge any such fee or credit any overpayment, to our Deposit Account No. 02-4377.

Respectfully submitted,

BAKER BOTTS L.L.P.

July 17, 2009

Date

/David Schalk/

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